

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10530562			
<b>Filing Date:</b>	07-Apr-2005			
<b>Title of Invention:</b>	Production method for thin-film crystal wafer, semiconductor device using it and production method therefor			
First Named Inventor/Applicant Name:	Masahiko Hata			
<b>Filer:</b>	Kelly G. Hyndman/Evette Ginn			
<b>Attorney Docket Number:</b>	Q87267			
Filed as Large Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				
Extension - 3 months with \$0 paid	1253	1	1050	1050

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				1050